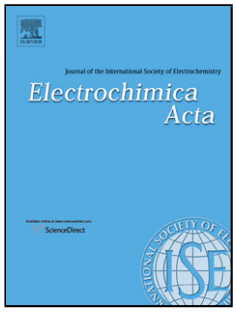


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# Investigation on Wire Electrochemical Micro Machining of Ni-based Metallic Glass

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## Highlights

- 1. WECMM with nanosecond pulses is proposed firstly for fabricating micro complex components based on metallic glasses.
- 2. Applicable electrolyte for WECMM of the Ni-based MG is discussed.
- 3. Significantly uniform machined surface is achieved in $H_2SO_4$ solution.
- 4. High machining efficiency and stability are obtained experimentally by modifying pulse waveforms and electrolyte compositions.
- 5. Complex microstructures of Ni-based MG are fabricated by WECMM with optimized parameters.

## Abstract

Metallic glasses (MGs) have been recognized as promising materials for realizing high-performance micro devices in micro electromechanical systems (MEMS) due to their excellent functional and structural characteristics. However, the applications of MGs are